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with SIC system for thin film developments:
Status and recent results***

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Characterization of superconducting samples with SIC system for thin film developments: status and recent results*

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Abstract

Within any thin film development program directed towards SRF accelerating structures, there is a need for an RF characterization device that can provide information about RF properties of small samples. The current installation of the RF characterization device at Jefferson Lab is Surface Impedance Characterization (SIC) system. The data acquisition environment for the system has recently been improved to allow for automated measurement, and the system has been routinely used for characterization of bulk Nb, films of Nb on Cu, MgB₂, NbTiN, Nb₃Sn films, etc. We present some of the recent results that illustrate present capabilities and limitations of the system.

INTRODUCTION

The development of new materials as well as understanding current limiting loss mechanisms and material behavior in RF fields calls for an RF system capable of high resolution ($\propto 1$ n Ω) surface resistance measurement device with a high magnetic field reach (greater than 200 mT). The system also should allow for a fast turn around and host sample sizes that can be accommodated in the standard material characterization systems. Over the years a number of sample RF characterization systems have been developed [1, 2, 3, 4, 5, 6, 7], but none of them has been able to match the resolution and field reach of the best SRF cavities. Still, RF characterization host cavities are widely used to characterize superconducting samples, and a number of systems are under development [8, 9, 10].

The current sample RF characterization system at Jefferson Lab is Surface Impedance Characterization (SIC) system. The system has been shown in the past to resolve RF surface resistance on the order of 1 $\mu\Omega$ and a field reach on the order of 10 mT. Presently, the system is been heavily used for niobium on copper thin film development and new material characterization in RF fields. This paper is the status report of the system: we summarize the experimental setup and characterization method, and show some of the recent results to illustrate SIC's capabilities.

EXPERIMENTAL SETUP

SIC system employs a cylindrical cavity loaded with high permittivity sapphire to reduce the TE₀₁₁ frequency to 7.4 GHz [11, 12]. A flat two inch sample under investigation forms a part of RF structure, but is thermally decoupled from the rest of the RF cavity, so that the RF cavity remains at the helium bath temperature (typically 2 K) while the temperature of the sample is varied. The dissipation induced by RF field on the sample is derived via the power compensation technique:

$$P_{RF}(H_{peak}, T_{sample}) = P_{heater}^{H=0;T=T_{sample}} - P_{heater}^{H=H_{peak};T=T_{sample}} \quad (1)$$

, where $P_{heater}^{H=0;T=T_{sample}}$ is the heater power needed to maintain the temperature of the sample at $T = T_{sample}$ with zero RF field in the cavity, and $P_{heater}^{H=H_{peak};T=T_{sample}}$ is the heater power needed to maintain the temperature of the sample at $T = T_{sample}$ with RF field in the cavity such that $H = H_{peak}$ on the sample. The average RF surface resistance of the sample can then be defined as:

$$R_{RF}(H_{peak}, T_{sample}) = \frac{P_{RF}(H_{peak}, T_{sample})}{k \cdot H_{peak}^2} \quad (2)$$

, where $k = 3.70 \cdot 10^7 \frac{W}{\Omega T^2} = 5.84 \cdot 10^{-5} \text{ m}^2$ is a constant related to the surface area of the sample exposed to RF fields and found with numerical simulations, and H_{peak} is the peak magnetic field on the surface of the sample.

The first part of SIC measurement is the measurement of loaded quality factor of the cavity as a function of the sample temperature using a network analyzer. Presently, Agilent's FieldFox N9915A, connected to the network for data communication, is used for loaded Q measurement. The Q loaded measurement is done with 3 dB technique and a typical Q_L versus temperature result is shown in Fig. 1 with bars representing random error.

After the network analyzer measurements a standard PLL RF system is connected to the cavity and the surface resistance is measured using the power compensation technique, Fig. 2. The stored energy, and hence RF field, is derived from the PLL measured power levels and the loaded quality factor measured with the network analyzer.

The output of phase modulated RF source is amplified by a 1 Watt RF amplifier, which generates peak magnetic fields of about 1 mT on the sample surface. 200 Watt amplifier has been procured to extend field reach and its implementation is foreseen.

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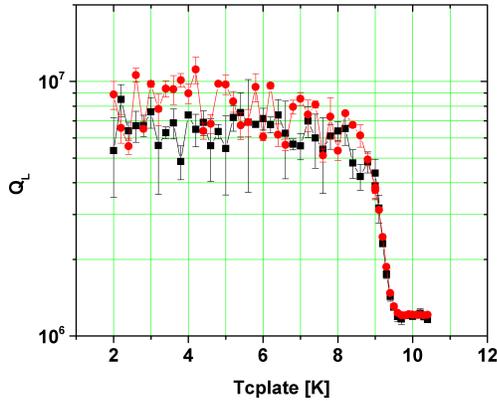


Figure 1: A representative measurement of loaded quality factor as a function of temperature is shown in this plot. One can see loaded quality factor of about 10^7 at lower temperatures. The quality factor drops as the sample temperature approaches the superconducting transition temperature of the sample. The bars show a random error deduced from several frequency scans with the network analyzer.

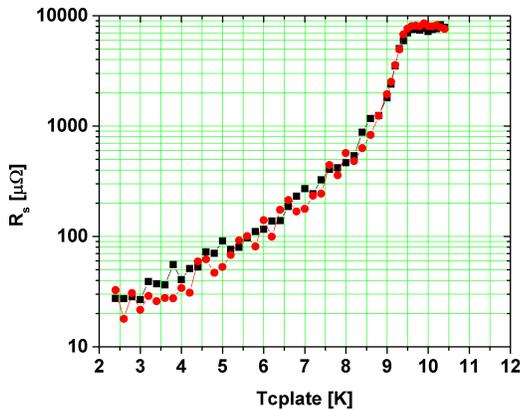


Figure 2: A representative measurement of RF surface resistance. The red and black data points are data for two subsequent measurement at different power levels without disassembly.

RESULTS AND DISCUSSION

Thin film ECR films results

SIC system has been used heavily to characterize niobium films on copper coated in electron cyclotron resonance (ECR) system at Jefferson Lab. In Fig. 3 recent measurement results for several films are presented.

Nb_3Sn results

We used a Nb chamber loaded with niobium samples, Sn, and $SnCl_2$ to produce Nb samples coated with Nb_3Sn . Two flat Nb samples in the chamber were fine grain and large grain niobium samples. After the coating the samples

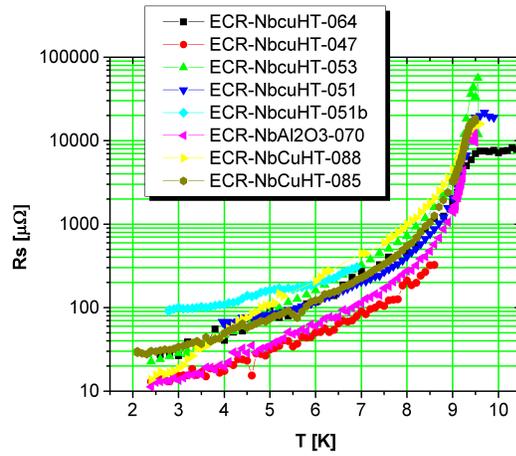


Figure 3: In this plot recent surface resistance measurements of niobium thin film coated on copper substrates with ECR technique are presented.

had visually different surface: the fine grain sample had a uniform coating, whereas the large grain sample has surface features, commonly referred as "droplets", similar to those observed in other studies. Surface resistance of both samples was measured in SIC system, Fig. 4. The large grain sample with "droplets" exhibits residual surface resistance of about $1\text{ m}\Omega$, which is almost two orders of magnitude higher than that of the fine grain sample with uniform coating, which exhibits residual surface resistance of about $20\ \mu\Omega$.

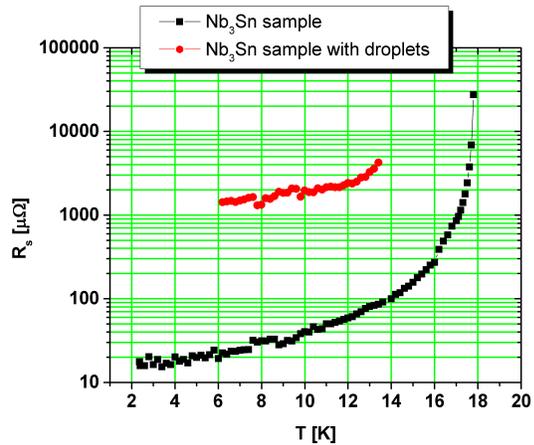


Figure 4: Surface resistance measurements of Nb_3Sn coated on large grain and fine grain samples are presented. The red circles are data for a Nb_3Sn coated large grain sample. The black squares are data for a Nb_3Sn coated fine grain sample.

$NbTiN$ results

SIC measurements are being done on the thin film multi-layer samples. One of the materials under study is $NbTiN$. Two $NbTiN$ films have been recently measured. One of the

samples was a thin film NbTiN coated on thin film Nb deposited with electron cyclotron resonance deposition system on bulk Cu sample with AlN and Al₂O₃ dielectric interlayers. Another NbTiN thin film was deposited on a bulk niobium sample with AlN dielectric interlayer. The quality factor measurements are shown in Fig. 5[top]. Both samples exhibit two transitions, one corresponding to NbTiN layer and the other to underlying superconducting Nb layer. The surface resistance measurements on these samples are still under way, but the film coated onto bulk niobium sample has higher quality factor at all temperatures, which implies lower surface resistance. In Fig. 5[bottom] we plotted the derivative of the RF transmission s₂₁ as a function of temperature. We use the s₂₁ derivative plots to infer the transition temperatures and transition temperature variation within the film. Again, NbTiN film on bulk niobium has a higher transition temperature and a sharper transition.

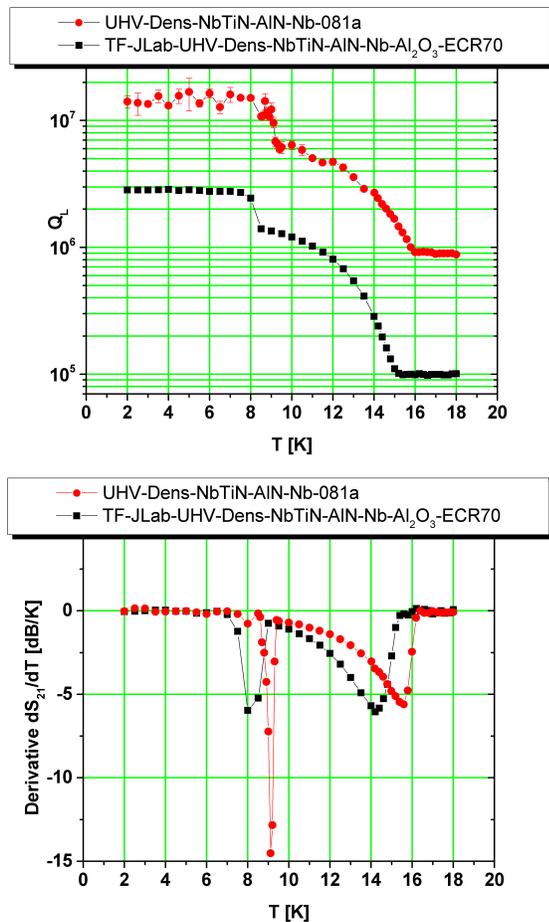


Figure 5: In the top plot the Q_L vs. T data is presented for two NbTiN films: the red circles correspond to the film coated on niobium with AlN dielectric interlayer; the black squares correspond to the film coated on Nb on Cu with AlN and Al₂O₃ dielectric interlayers. In the bottom plot the derivative of s₂₁ transmission is presented. The data illustrates transition temperature and transition temperature variation for both NbTiN and underlying Nb films.

CONCLUSIONS

Surface impedance characterization (SIC) cavity has been routinely used to characterize flat two inch diameter samples coated with various materials. Recent automation of data acquisition allowed for a higher capture rate and autonomous measurement. In this contribution we presented some measurements of thin film niobium, thick film Nb₃Sn, and superconductor-insulator-superconductor sample that illustrated the setup, its applications, and the capabilities of the system. The present challenges towards extending system capabilities include the increase in the field reach, understanding of the quality factor limitations and high residual resistance in some samples, and improvements in systems RF coupling.

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